

## Notice of References Cited

Application/Control No.

10/049,930

Examiner

John Rivell

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Art Unit

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## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
- 1	Α	US-2002/0047304	04-2002	Bolitho et al.	303/119.2
	В	US-6,116,269	09-2000	Maxson, William R.	137/557
	С	US-6,155,257	12-2000	Lurie et al.	128/204.23
	D	US-6,298,731	10-2001	Wade et al.	73/756
	E	US-6,374,679	04-2002	Babala et al.	73/715
	F	US-			
	G	US-			
	Н	US-			
	ı	US-	· <del>-</del>		
	J	US-			
	К	US-			
	L	US-			
	М	US-			

## **FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q					
	R					
	S					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)					
	U						
	v						
	w						
	х						

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.